

PTO/SB-08B (07-05)
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Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Complete if Known

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| Application Number | 10/539,261 |
| Filing Date | June 16, 2005 |
| First Named Inventor | Uwe Lehmann |
| Art Unit | 1742 |
| Examiner Name | Not yet assigned |
| Attorney Docket Number | P&P-100 |

Sheet 1 of 2

NON PATENT LITERATURE DOCUMENTS

Include name of the author (in CAPITAL LETTERS), title of the article, (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

| Examiner Initials* | Cite No. ¹ | T ² |
|--------------------|---|----------------|
| R1 | FEUSTEL, A. <i>et al.</i> , "A Micro Mass Spectrometer," <i>Sensor Kongressband</i> , 1995, pages 465-470. | |
| R2 | FEUSTEL, A. <i>et al.</i> , "A Microsystem Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 1994, pages 299-304. | |
| R3 | GREVESMÜHL, B. "Miniaturisierte Gaschromatographie-Module verbessern Prozesse in der Chemie," <i>P&A Kompendium</i> , 2003/2004, pages 104-105 | |
| R4 | LEHMANN, U., "Analysis in miniature," <i>Vacuum Solutions</i> , November/December 1998, pages 13-15. | |
| R5 | LEHMANN, U., "Autarky Gas Chromatographic System Realized in MEMS Technology on a Credit Card-Sized Board," <i>Abstracts Pittcon</i> , 2005, 180-9. | |
| R6 | LEHMANN, U., "Kleinste Elisse messen," <i>Journal Forschung und Entwicklung</i> , Heft 6, 2002, Vol. 44, pages 32-35. | |
| R7 | LEHMANN, U. <i>et al.</i> , "A micro gas chromatograph based on a plasma polymerized siliconorganic stationary phase," <i>Sensor Kongressband II</i> , 1997, pages 151-153. | |
| R8 | LEHMANN, U. <i>et al.</i> , "Micro machined analytical gas chromatograph with a plasma polymerised stationary phase," <i>Sensor Proceedings II</i> , 2001, pages 487-492. | |
| R9 | LEHMANN, U. <i>et al.</i> , "Micro machined gas chromatograph based on a plasma polymerised stationary phase," <i>Micro Total Analysis Systems</i> , 2000, pages 167-170. | |
| R10 | LEHMANN, U. <i>et al.</i> , "Mikrogaschromatograph basierend auf einer plasmapolymersierten siliziumorganischen stationären Phase," <i>Jahrg.</i> , 1999, Vol. 53, No. 7, pages 47-49 | |

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| Examiner Signature | /Shogo Sasaki/ | Date Considered | 02/27/2009 |
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| | R11 | LEHMANN, U. et al., "A Miniaturised Gas Chromatographic Module on a Credit Card Sized Motherboard," <i>Sensor Proceedings</i> , 2003, pages 157-161. | |
| | R12 | LEHMANN, U. et al., "A miniaturized gas chromatograph for autonomous and longtime measurements," <i>Sensor Proceedings I</i> , 1999, pages 155-158. | |
| | R13 | LEHMANN, U., "A Packed Column Realized on a 1 cm ² Sized Silicon Glass Chip for Permanent Gas Separation," <i>Abstracts Pittcon</i> , 2005, 1910-5P. | |
| | R14 | LEHMANN, U., "World's Smallest, Self-Sufficient Gas Chromatography Module from SLS Micro Technology," <i>Abstracts Pittcon</i> , 2004, 1100-100. | |
| | R15 | "Small is Beautiful," <i>The Column</i> , July 2005, pages 22-23. | |
| | R16 | PETZOLD, G. et al., "A Micro Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 2001, pages 224-226. | |
| | R17 | SIEBERT, P. et al., "Processing of Complex Microsystems: A Micro Mass Spectrometer," <i>Symposium on Design, Test, and Microfabrication of MEMS and MOEMS</i> , March-April 1999, Vol. 3680, pages 562-571, Paris, France. | |
| | R18 | SIEBERT, P. et al., "Surface microstructure/miniature mass spectrometer: processing and applications," <i>Appl. Phys. A</i> , 1998, Vol. 67, pages 155-160. | |
| | R19 | | |
| | R20 | | |

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